REMARKS

Claims 7, 19-24, 30, 32 and 34 were pending in the present Application. Claims 35-71 have been added, leaving claims 7, 19-24, 30, 32 and 34-71 for consideration upon entry of the present amendment. No new matter has been added by way of amendment. For example, support for Claims 35-57 can be found at least in claims 1-6, 8-18, 27-29, 31, and 33 (now cancelled); support for claims 57-61 can be found at least from page 25, line1 through page 29, line 16; support for claims 62-66 can be found at least from page 11, line 20 through page 12, line 5; and support for claims 67-71 can be found at least from page 24, lines 12-28.

Reconsideration and allowance of the entire case is respectfully requested in view of the above amendments and the following remarks.

Claim Rejections Under 35 U.S.C. § 102(e)

Claims 7, 19, 20-24, 30, 32 and 34 stand rejected under 35 U.S.C. § 102(e), as allegedly anticipated by U.S. Patent No. 6,255,755 to Ikuko et al. Applicants respectfully traverse this rejection.

To anticipate a claim, a reference must disclose each and every element of the claim. Lewmar Martne v. Varient Inc., 3 U.S.P.Q.2d 1766 (Fed. Cir. 1987).

Claims 7, 19, 32, and 34 comprises, *inter alia*, the following elements: "causing a material from said layer material source to attach to a first region of said substrate through said opening, while relative positions of said substrate, said mask, and said layer material source are set to a first positional relationship; ... causing said material to attach to a second region of said substrate through said opening, while relative positions of said substrate, said mask, and said layer material source are set to said second positional relationship." Ikuko does not disclose at least these elements. Rather, as is evidenced by the three different contrasts shown in Figures 9(a)-(d) Ikuko discloses using three different materials. Ikuko discloses using a mask to cause: a first material to attach to a first region of a substrate; a second material to attach to a second region of a substrate; and a third material to attach to a third region of a substrate. Ikuko does not teach or suggest using a mask to attach a material to both a first region of a substrate while relative positions of said substrate, said mask, and YKI-0078
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said layer material source are set to a first positional relationship and using the mask to attach the material to second region of a substrate while the relative positions of said substrate, said mask, and said layer material source are set to said second positional relationship. Therefore, Ikuko does not teach or disclose all of the elements of claims 7, 19, 32, and 34.

Applicants respectfully request withdrawal of the rejection to claims 7, 19, 20-24, 30, 32 and 34.

Claim Rejection Under 35 U.S.C. § 103(a)

Claim 24 stands rejected under 35 U.S.C. § 103(a), as allegedly unpatentable over U.S. Patent No. 6,255,775 to Ikuko et al. in combination with U.S. Patent No. 6,087,274 to Tonucci et al.

Claim 24 depends from claim 19, and as explained above, Ikuko does not teach or disclose all of the elements of claim 19. Tonucci does not teach or disclose using a mask to attach first material to both a first region of a substrate while relative positions of said substrate, said mask, and said layer material source are set to a first positional relationship and using the mask to attach the material to second region of a substrate while the relative positions of said substrate, said mask, and said layer material source are set to said second positional relationship. Tonucci does not cure the deficiencies of Ikuko. Therefore, Ikuko in combination with Tonucci does not teach or disclose all of the limitations of claim 24.

Applicants respectfully request withdrawal of the rejection to claim 24.

Newly added Claims 35-71

With respect to newly added claims 35-56, Claims 7, 35, 44, 55, and 56 recite, *inter alia*, the following elements: "causing a material from said layer material source to attach to a first region of said substrate through said opening, while relative positions of said substrate, said mask, and said layer material source are set to a first positional relationship; ... causing said material to attach to a second region of said substrate through said opening, while relative positions of said substrate, said mask, and said layer material source are set to said second positional relationship." As explained above, Ikuko does not teach or disclose at least these

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limitations. Therefore, Ikuko does not anticipate the newly added claims 35-56. With respect to newly added claims 57-71, these claims variously include the elements of claims 7, 19, 35, and 44. These claims include additional features and are therefore not anticipated by Ikuko, more specifically: claims 57 and 58 include said individually patterned layer made of said material is formed in pixels at different positions on said substrate using said mask; claims 59-61 include wherein said emissive layer of said emissive material is formed in at least two pixels which are at different positions on the substrate and which are associated with a same color using the mask; claims 62- 66 include wherein said mask is placed on a mask support and a region of said glass substrate not covered by said mask is covered by said mask support; and claims 67-71 include wherein said substrate and a set of said mask and said material source are moved relative to each other. Ikuko does not disclose that an individually patterned layer made of a single material is formed in pixels at different positions using a single make by changing a relative position of the mask and the substrate. Rather, Ikuko discloses using a single mask to for a single layer that includes three different materials (red, green, and blue luminous layers) that are individually formed from different materials. Additionally, Ikuko does not disclose or suggest a mask support structure.

Conclusion

In view of the foregoing, it is respectfully submitted that the instant application is in condition for allowance. Accordingly, it is respectfully requested that this application be allowed and a Notice of Allowance issued. If the Examiner believes that a telephone conference with Applicants' attorneys would be advantageous to the disposition of this case, the Examiner is cordially requested to telephone the undersigned.

If there are any additional charges with respect to this Amendment or otherwise, please charge them to Deposit Account No. 06-1130.

Respectfully submitted,

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